

OGOSH43USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	)	
	)	Examiner:
Yuichiro Shindo	)	
	)	Group Art Unit:
Application No.:	)	
	)	
Corresponding International Filing No.:	)	
<b>PCT/JP2004/005389</b>	)	
	)	
Filed: Herewith	)	
	)	
For: HIGHLY PURE HAFNIUM	)	
MATERIAL, TARGET AND	)	
THIN FILM COMPRISING THE	)	
SAME AND METHOD FOR	)	
PRODUCING HIGHLY PURE	)	
HAFNIUM	)	

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FIRST PRELIMINARY AMENDMENT**

Sir:

**Before calculating the filing fee**, please amend the above-identified patent application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page two of this paper.

**Remarks** begin on page four of this paper.